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FOREIGN PATENT DOCUMENTS						
Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages Or Relevant Figures Appear	T ⁶
		Country Code ³ Number ⁴ Kind Code ⁵ (if known)				
		DE 101 36 219 A1	02-06-2003	Conti Temic Microelectronic		✓
		DE 197 39 961 C1	04-15-1999	Siemens AG		
		EP 0 794 558 A1	09-10-1997	Ford Motor Company		

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Substitute for form 1449/PTO <h2 style="text-align: center;">INFORMATION DISCLOSURE STATEMENT BY APPLICANT</h2> <p style="text-align: center;"><i>(Use as many sheets as necessary)</i></p>		Complete if Known	
		Application Number	10/591,686
		Filing Date	09/05/2006
		First Named Inventor	Ronald Kumst
		Art Unit	2856
		Examiner Name	Gissel, Gunnar J.
Sheet	2	of	2
		Attorney Docket Number	LEO 004 PA

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		BERGSTROM, PAUL L. et al.; "Thermally Driven Phase-Change Microactuation"; Journal of Microelectromechanical Systems; March 1, 1995; pages 10-17; Vol. 4, No. 1; IEEE, Inc. New York	
		LAPADATU, A. COZMA et al.; "A new concept for a self-testable pressure sensor based on the bimetal effect"; Sensors and Actuators; 2000; pages 69-73; Vol. 82; Elsevier Science S.A. ; Lausanne CH	
		NESE, MARTIN et al.; "New method for testing hermeticity of silicon sensor structures"; Sensors and Actuators A; 1996; pages 349-352; Vol. 53; Elsevier Science S.A.	
		WAEELTI, M. et al.; "Package Quality Testing Using Integrated Pressure Sensor"; The International Journal of Microcircuits and Electronic Packaging; January 1999; Pages 49-56; Vol. 22, No. 1; International Microelectronics and Packaging Society; U.S.	

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